



RHM-US020574

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Patent Art Unit: 3742
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Toshikuni Shinohara	:	Examiner: Tu Ba Hoang
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Serial No.: 10/707,989	:	
	:	
Filed: Jan. 30, 2004	:	
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For: Plasma Processing Apparatus	:	

**INFORMATION DISCLOSURE STATEMENT WITH CERTIFICATION**

Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant brings the following references to the Examiner's attention and requests that they be considered and made of record in this application. Also attached is a completed PTO-1449 form.

1. US patent application publication 2002/0079294 to Tadera et al., published June 27, 2002 (corresponding to US Patent No. 6,753,496).
2. US patent application publication 2002/0123200 to Yamamoto et al., published Sept. 5, 2002 (corresponding to US Patent No. 6,783,628).
3. US Patent No. 6,325,018 to Hongoh, published Dec. 4, 2001
4. US patent application publication 2001/0050058 to Yamamoto et al., published Dec. 13, 2001 (corresponding to US Patent No. 6,620,290).
5. Japanese unexamined patent application publication H11-26190A (together with English language machine translation of same provided by the Japan Patent Office), published January 29, 1999.
6. Japanese unexamined patent application publication H11-067492A (together with English language machine translation of same provided by the Japan Patent Office), published March 9, 1999 .

7. Japanese unexamined patent application publication H10-275696A (together with English language machine translation of same provided by the Japan Patent Office), published October 13, 1998 .

8. Japanese unexamined patent application publication H10-255998A (together with English language machine translation of same provided by the Japan Patent Office), published Sept. 25, 1998.

9. US Patent No. 5,698,036 to Ishii et al., published Dec. 16, 1997.

10. Japanese unexamined patent application publication H08-241797A (together with English language machine translation of same provided by the Japan Patent Office), published Sept. 17, 1996.

11. Japanese unexamined patent application publication H08-274083A (together with English language machine translation of same provided by the Japan Patent Office), published October 18, 1996.

12. Japanese unexamined patent application publication H05-129095A (together with English language machine translation of same provided by the Japan Patent Office), published May 25, 1993.

I hereby certify that each item of information contained in this information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement.

**No fee is believed to be required in view of the above certification.** However, Applicant authorizes the Commissioner of Patents to charge payment of the petition fee under 37 CFR § 1.17(p) *if required* and any other fees associated with this communication or credit any overpayment to Deposit Account No. 19-2042.

Respectfully submitted,



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Dated: March 18, 2005

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